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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: HIMI et al.

Serial No.: 10/716,606

Filed: 11/20/2003

Title: METHOD FOR MANUFACTURING  
SEMICONDUCTOR SUBSTRATE

Atty. Dkt.: 01-100-DIV

Art Unit: 2813

Examiner: Thanhha S. PHAM

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: 2 October 2006

**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being facsimile transmitted to the USPTO (Fax. No. 571-273-8300) on 2 October 2006

Typed Name: Kerry S. Culpepper.

Signature: **REPLY UNDER 37 CFR 1.116**

Sir:

In response to the office action mailed 2 June 2006, please amend the application as follows:

Remarks begin on page 2 of this paper.